

### US DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

APPLICANT: MARTIN RICHARDSON

EUV, XUV, AND X-RAY WAVELENGTH SOURCES CREATED FROM LASER PLASMA

PRODUCED FROM LIQUID METAL SOLUTIONS, AND NANO-SIZE PARTICLES IN SOLUTIONS

# LIST OF ART CITED BY APPLICANT

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|    | AG       | 5.052.034    | 09/24/91   | Schuster          | 378   | 121      | 10/29:90    |
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Courtney Thomas 10.15.04



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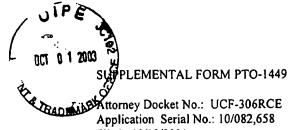
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Filed: 10/19/2001 First Named Inventor: Martin Richardson

Examiner: Thomas, Courtney D.

Group: 2882

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